



Information Disclosure Statement  
USPN 10/686,545  
March 10, 2004  
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Form PTO-1449 (Modified)	ATTY DOCKET NO. B-44721NP 620761-8	U.S. SERIAL NO. 10/686,545
LIST OF PATENTS AND PUBLICATIONS STATEMENT	APPLICANTS James P. BAUKUS, et al.	
	FILING DATE October 14, 2003	GROUP <del>2811</del> 2829

**U.S. PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	ISSUE DATE	NAME	CLASS	SUB- CLASS	FILING DATE or 102(e) DATE IF APPROPRIATE
LT	5,783,846	7/1998	Baukus et al.	257	204	
LT	5,866,933	2/1999	Baukus et al.	257	368	
LT	5,973,375	10/1999	Baukus et al.	257	399	
LT	6,117,762	9/2000	Baukus et al.	438	618	

**FOREIGN PATENT DOCUMENTS**

DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**

LT	Rovedo, Nivo, et al., "Introducing IBM'S First Cooper Wiring Foundry Technology: Design, Development, and Qualification of CMOS 7SF, a 18- $\mu$ m Dual-Oxide Technology for SRAM, ASICs, and Embedded DRAM," MicroNews, Fourth Quarter 2000, Vol 6, No. 4, INTERNET: < <a href="http://www-3.ibm.com/chips/micronews/vol6_no4/rovedo.html">http://www-3.ibm.com/chips/micronews/vol6_no4/rovedo.html</a> > 7 pages (February 15, 2002).
LT	Sze, S.M., VSLI Technology, McGraw-Hill, pp. 99, 447, 461-465 (1983).

EXAMINER <i>Uachun</i>	DATE CONSIDERED 4/3/04
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



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## U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	ISSUE DATE	NAME	CLASS	SUB- CLASS	FILING DATE or 102(e) DATE IF APPROPRIATE
LF	6,207,479 B1	3/2001	Liew et al.	438	129	
LF	6,413,847, B1	7/2002	Yeh et al	438	598	
LF	2002/0024148 A1	2/2002	Itoh	257	784	

## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO
LF	1 193 758 A1	4/2002	EP			
LF	2001-284357	10/2001	JP			abstract
LF	02/43147 A1	5/2002	WO			abstract

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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EXAMINER <i>Chalman</i>	DATE CONSIDERED 11/3/04
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